



AF JFW

THE UNITED STATES PATENTS AND TRADEMARK OFFICE

K-1984

Applicant : Yasumi Sago et al.
Title : ELECRO-STATIC CHUCKING MECHANISM AND
SURFACE PROCESSING APPARATUS
Serial No. : 09/879,934
Filed : June 14, 2001
Group Art Unit : 1763
Examiner : Ram N. Kackar

Hon. Commissioner of Patents
P.O. Box 1450, Alexandria, VA 22313-1450

August 4, 2005

AMENDMENT AFTER FINAL ACTION

Sir:

In response to the final Action of May 9, 2005, please amend
the application, as follows:

Amendments to the Claims

Remarks